REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

MAIL STOP RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Application Number		10/053,585
Confirmation Number		3468
Filing Date		January 24, 2002
First Named Inventor		Masayuki NAYA
Group Art Unit		1641
Examiner Name		Christopher L. Chin
Matter Number		Q66584
Title	SURFACE PLASMON RESONANCE MEASURING CHIP AND METHOD OF MANUFACTURE THEREOF	

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000, provides for continued examination of an utility or plant application filed on or after June 8, 1995 SURFACE PLASMON RESONANCE MEASURING CHIP AND METHOD OF MANUFACTURE THEREOF			
This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.			
 1. SUBMISSION REQUIRED UNDER 37 C.F.R. § 1.114 a. Previously submitted i. Please enter and consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on ii. Consider the arguments in the Appeal Brief or Reply Brief previously filed on iii. Other 			
b. Amendment/Reply ii. Affidavit(s)/Declaration(s) iii. Information Disclosure Statements (IDS) iv. Petition for Extension of Time v. Other 2. MISCELLANEOUS a. Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a period of months b. Other 3. FEES			
The statutory fee of \$790.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is also directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.			
CORRESPONDENCE ADDRESS Direct all correspondence to the address for SUGHRUE MION, PLLC filed under the Customer Number listed below: WASHINGTON OFFICE 23373 CUSTOMER NUMBER			
SIGNATURE OF ATTORNEY			
Name Susan P. Pan Registration No. 41,239			
Signature American Date March 19, 2007			